

FORM PTO-1449		US Dept. of Commerce Patent and Trademark Office		ATTORNEY DOCKET NO.		SERIAL NO.	
INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)		APPLICANT Chengyong Xu, et al.		FILING DATE December 13, 2001		GROUP TBA	
IDC US Ref 16		U.S. PATENT DOCUMENTS					
EXAMINER INITIAL	PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
1/4	AA 5,204,134	4/20/1993	Kilkin, et al.	Girsh			
	AB 5,535,323	7/16/1996	Kilkin, et al.				
	AC 5,711,816	1/27/1998	Kilkin, et al.				
	AD 6,171,943	1/9/2002	Mendel, et al.			01/09/2001	
	AE 4,745,169	5/17/1988	Sugiyama, et al.				
	AF 4,733,370	7/3/1988	Kay, et al.				
	AG 6,114,500	9/3/2000	Mord, et al.				
	AH 5,043,789	8/27/1991	Linda, et al.				
	AI 4,871,616	10/3/1989	Kimura, et al.				
	AJ 5,484,867	1/16/1996	Lichtenhan, et al.				
	AK 4,670,255	6/2/1987	Polozynski, et al.				
	AL 5,047,492	9/10/1991	Weidner, et al.				
	AM 5,210,230	3/11/1993	Wetzel, et al.				
	AN 4,374,110	2/13/1983	Dannell, et al.				
	AO 4,154,689	3/29/1979	Ashby, et al.				
1/4	AP 5,804,040	9/8/1998	Asai, et al.				
FOREIGN PATENT DOCUMENTS							
IDC For Ref	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
1/4	AQ JP 50-111198	1/28/1974	Japan			X (abstract only) X	
OTHER DOCUMENTS (including Author, Title, Journal Name, Page Number, Etc.)							
1/4	AR	Mikita, et al., "Thermolysis of Polyhedral Oligomeric Silsesquioxanes (POSS) Macromolecules and POSS-Siloxane Copolymers", Chem. Mater., 1996, 8, pp. 1250-1259.					
1/4	AS	Ravi K. Laxman, Neil Hendrix Barry Arkins, Terry A. Toller "Synthesizing Low-K CVD Materials for Pub Use" Semiconductor International, 11/1/2000					
Continue on Page							
EXAMINER 1/4 Hershman				DATE CONSIDERED 2/24/03			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							